



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Christian Wagner et al.                      Art Unit : 2161  
Serial No. : 09/934,817                                      Examiner : Etienne Pierre Leroux  
Filed : August 21, 2001                                      Conf. No. : 9363  
Title : OPTICAL ARRANGEMENT AND PROJECTION EXPOSURE SYSTEM FOR  
MICROLITHOGRAPHY WITH PASSIVE THERMAL COMPENSATION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

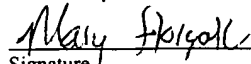
Prior to examination, please amend the application as indicated on the following pages.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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